

# How a single defect can affect silicon nano-devices

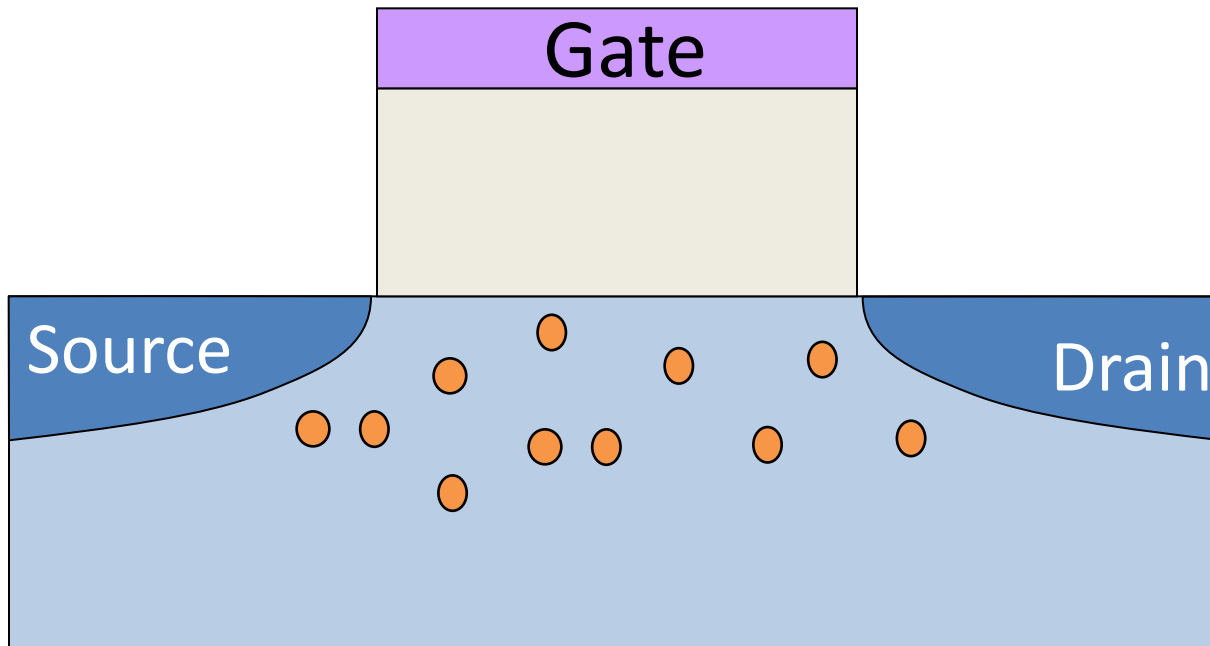
**Ted Thorbeck**

**tedt@nist.gov**



# The Big Idea

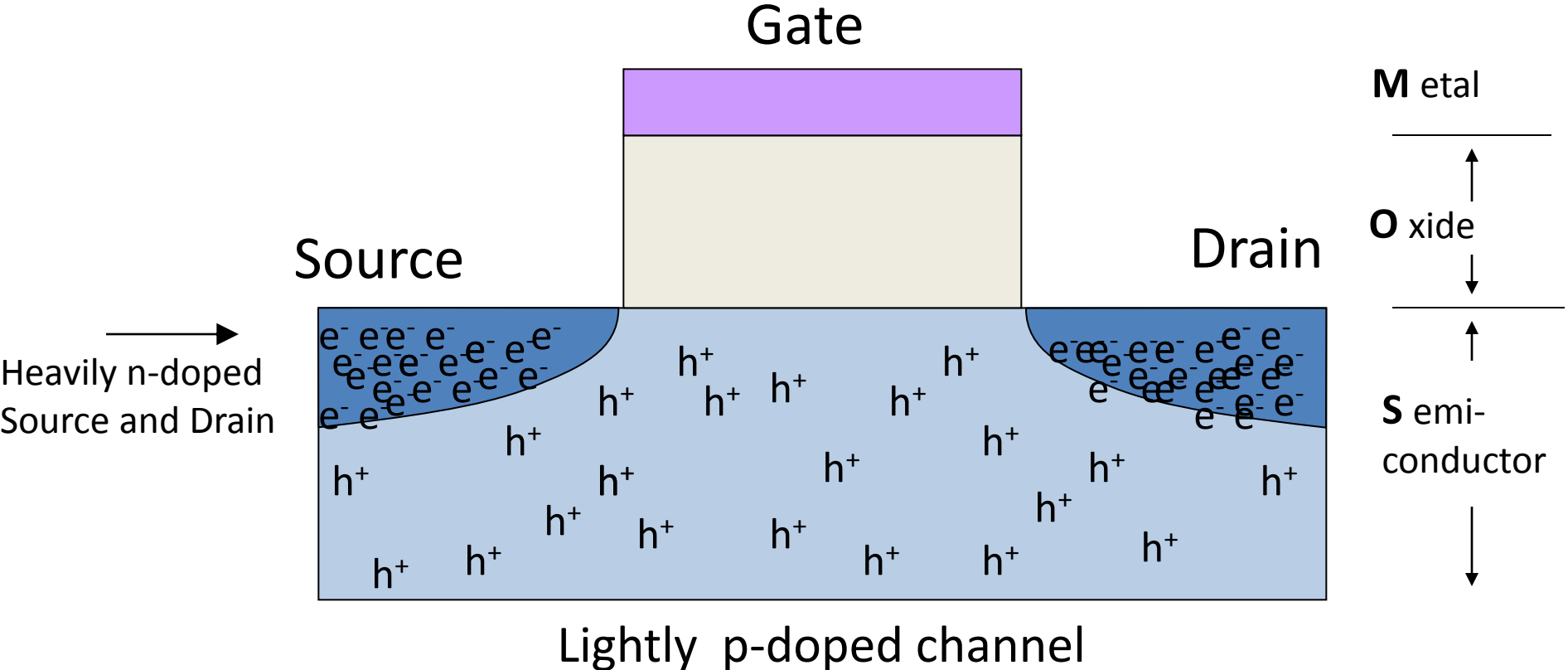
- As MOS-FETs continue to shrink, single atomic scale defects are beginning to affect device performance



# Outline

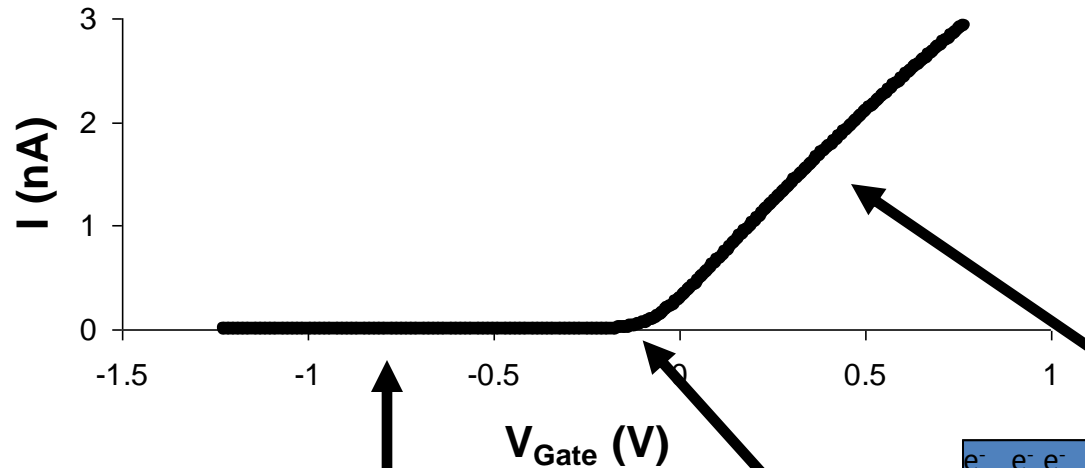
- The impact of a single atom on a MOSFET
- Locating a single atom in a transistor
- The potential for a single atom

# Review of MOS-FETs I



# Review of MOS-FETs II

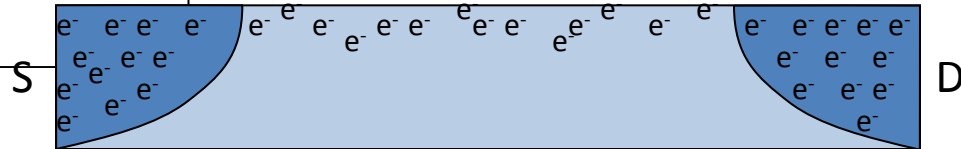
Typical MOS-FET Curve - 300 K



Gate

Positive

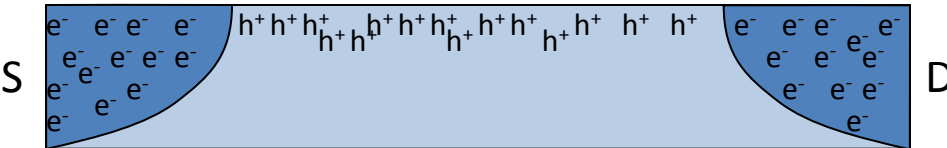
Electrons Invert



Gate

Negative

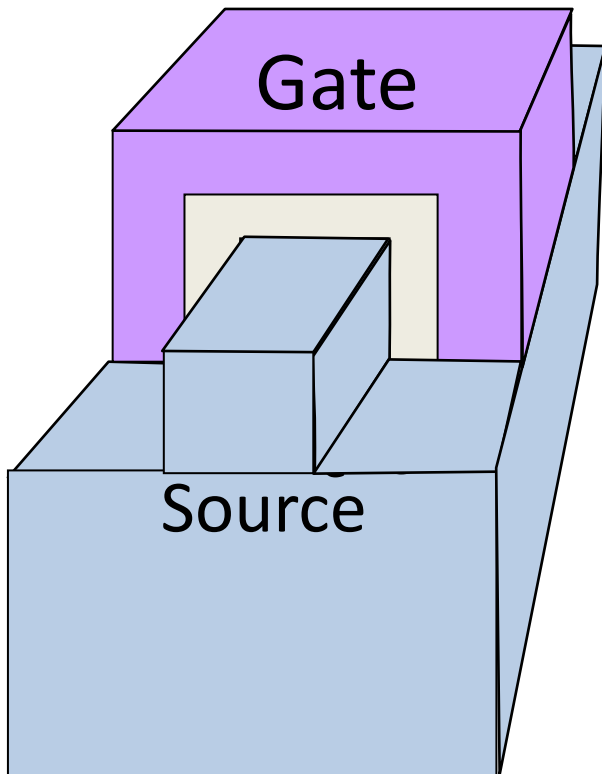
Holes Accumulate



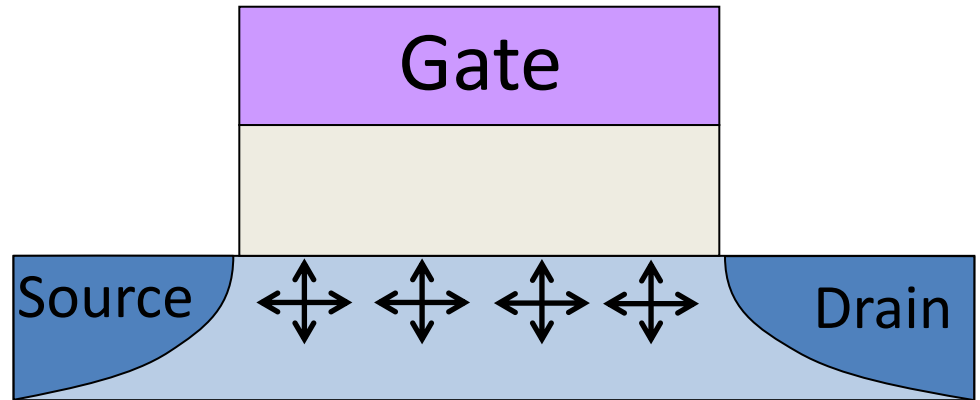
Threshold Voltage  
( $V_T$ )

# Not just shrinking....

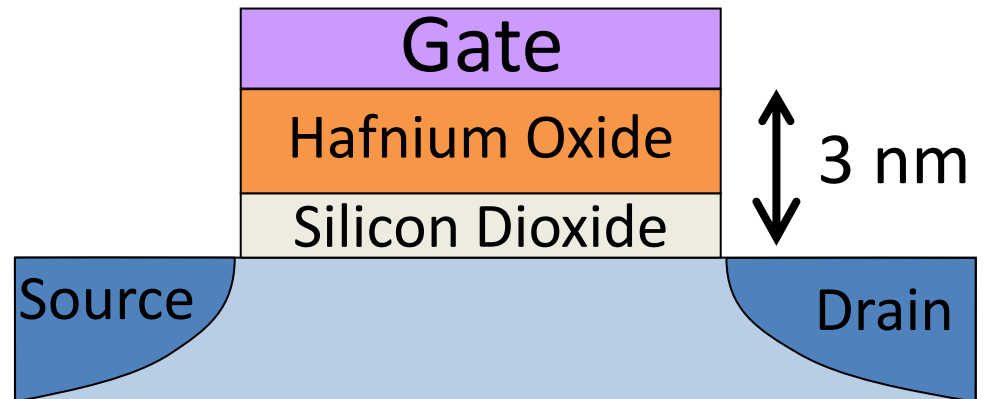
Planar to 3D



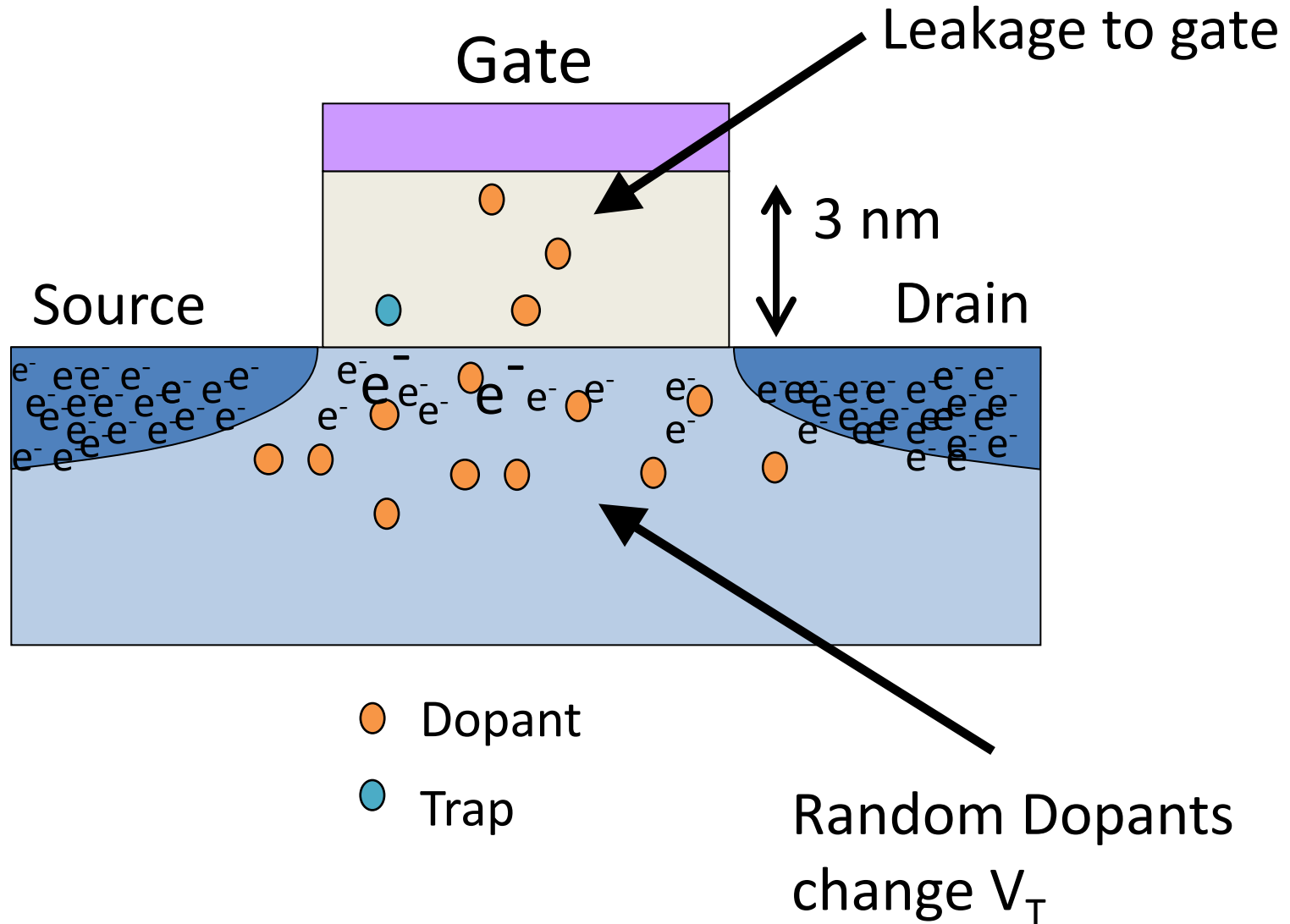
Strain



High- $\kappa$  dielectrics



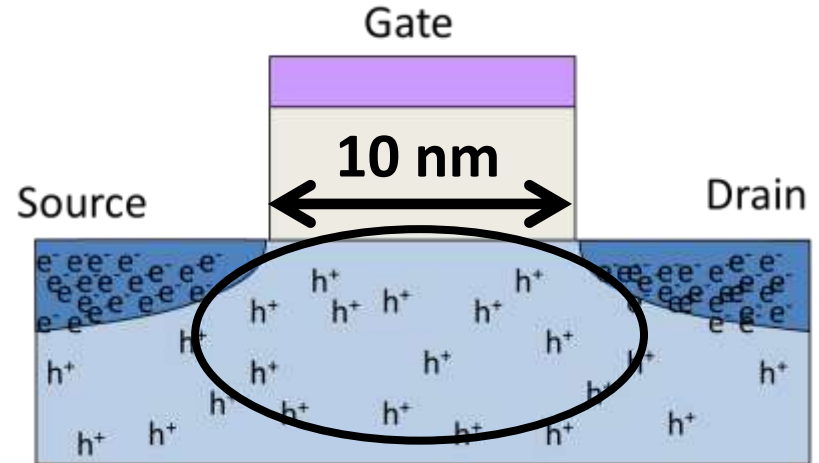
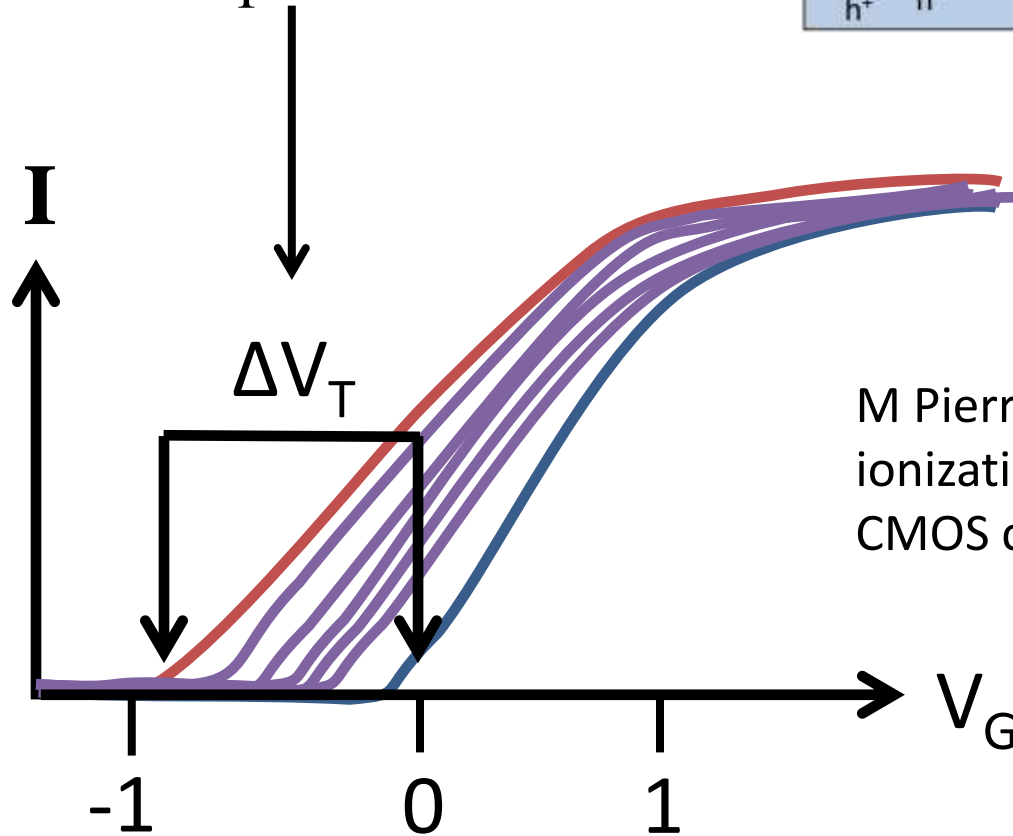
# Atomic Scale Defects



# Threshold Voltage

25 devices studied,

$$\Delta V_T \approx 1 \text{ V}$$



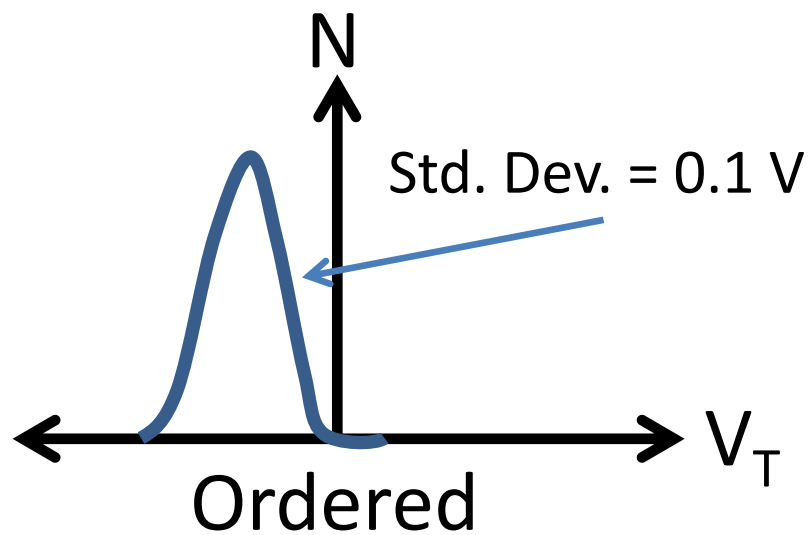
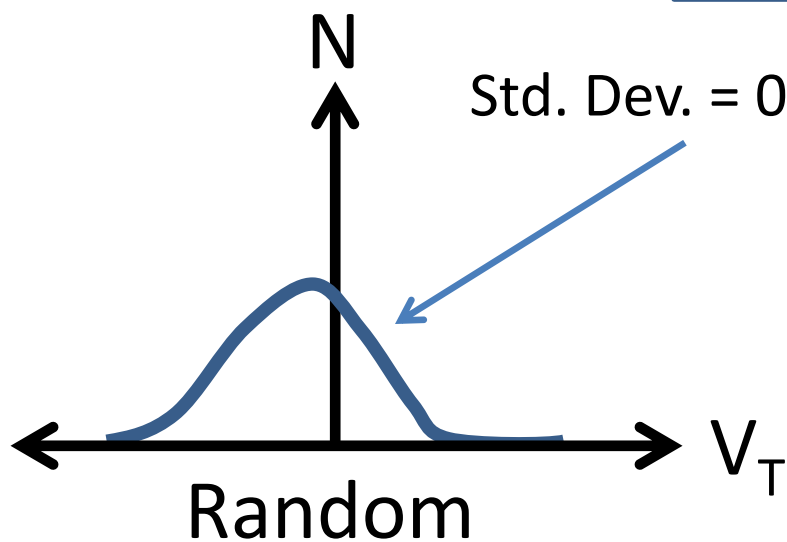
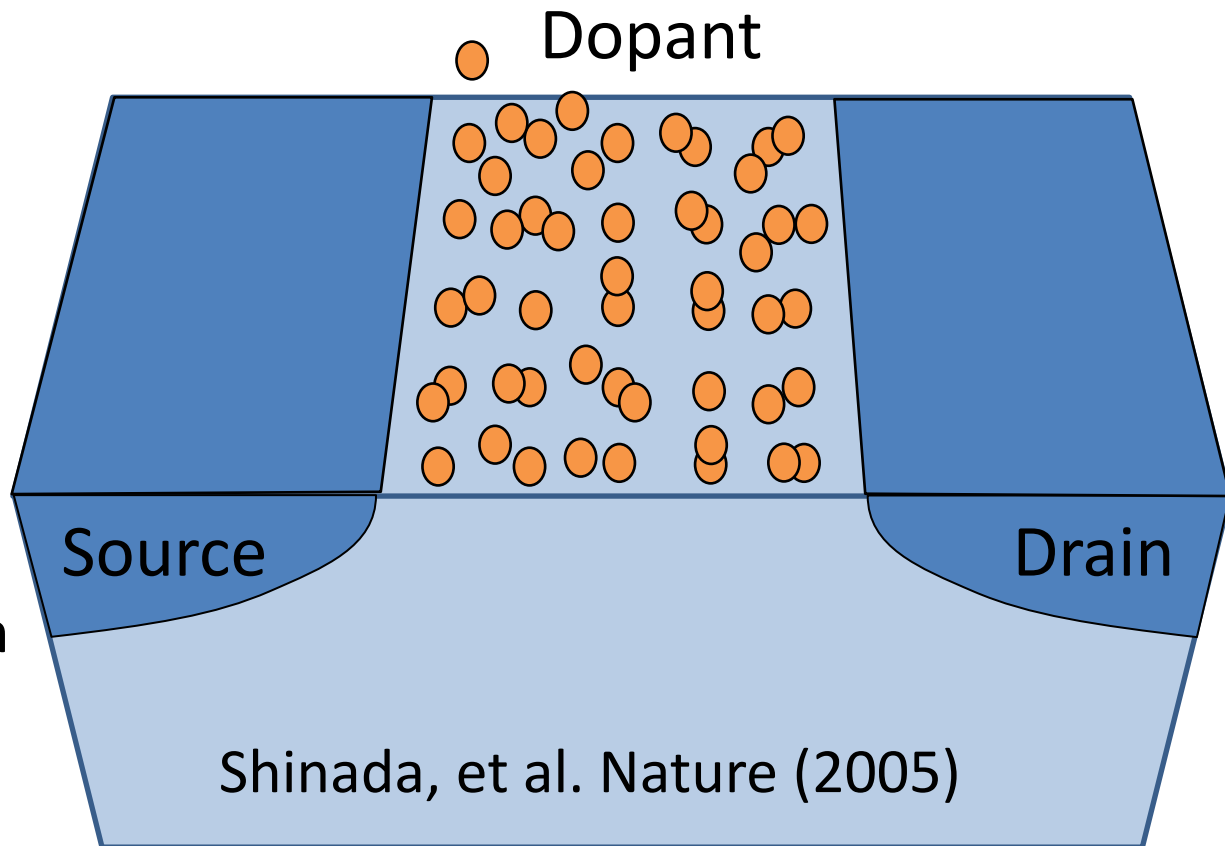
$\sim 10\text{s of dopants}$

M Pierre, et al. "Single-donor ionization energies in a nanoscale CMOS channel," Nature Nano, 2010



# Ordered Dopant Arrays

→  
Heavily n-doped  
Source and Drain



# Outline

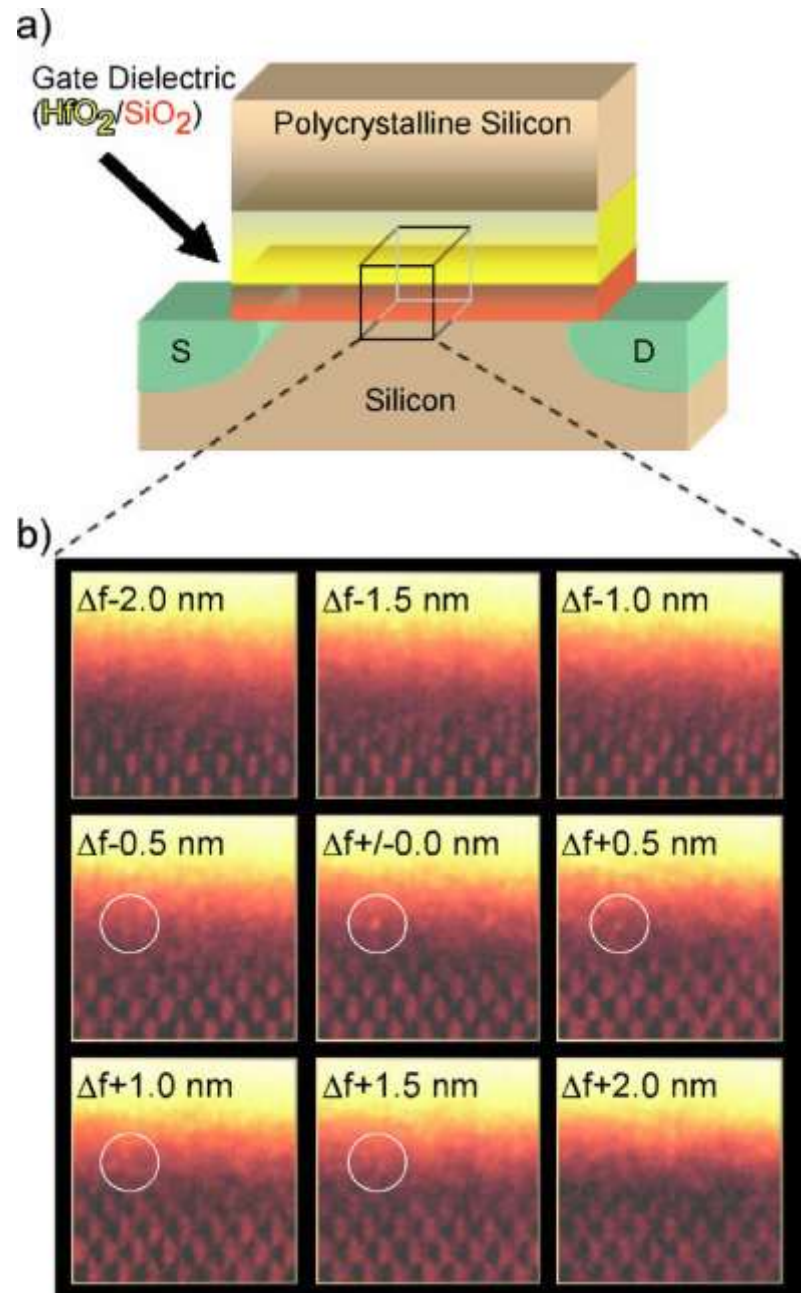
- The impact of a single atom on a MOSFET
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# Looking for a single atom

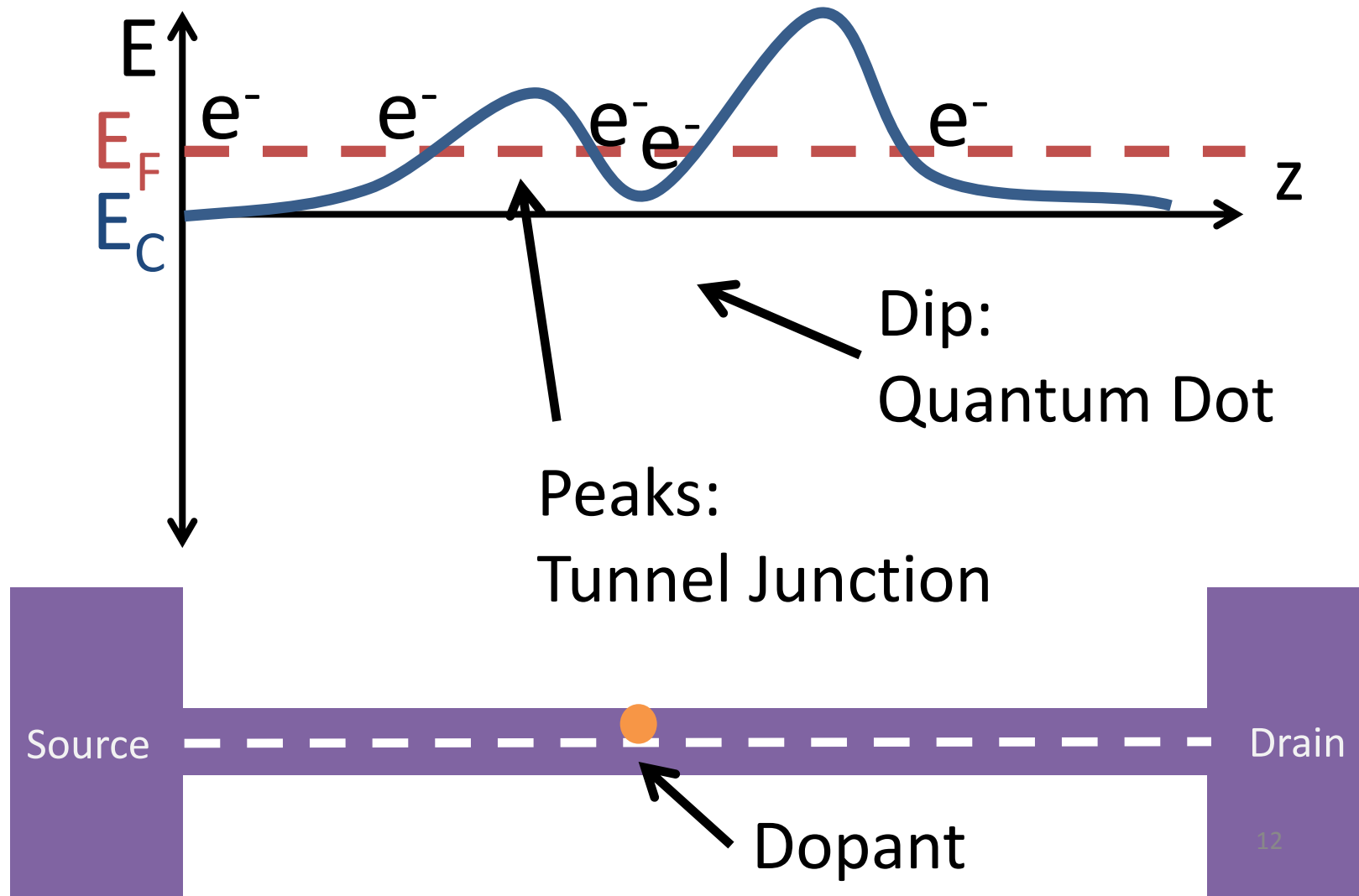
Annular dark-field scanning-TEM

Need to chop up device to look at it

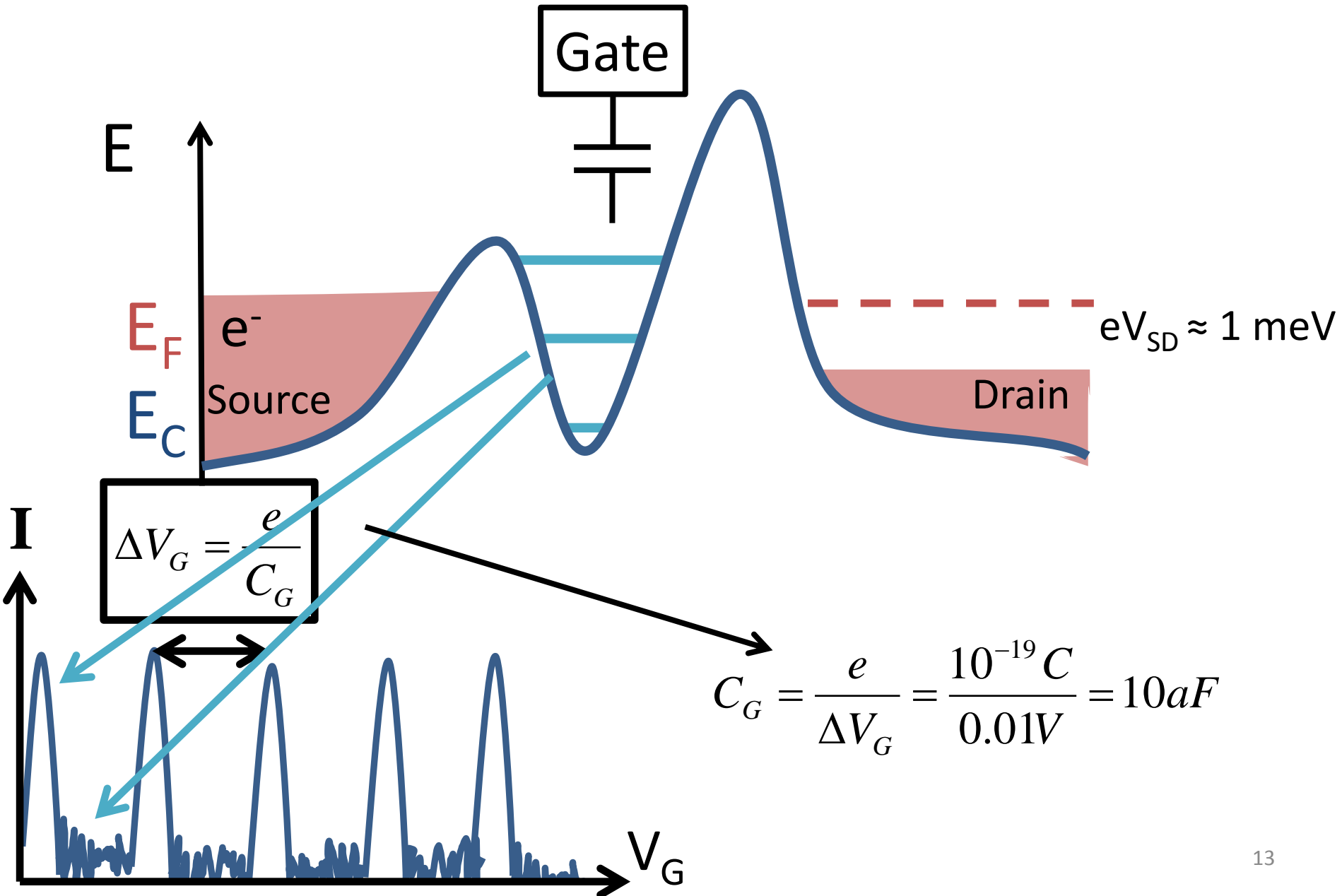
K. Van Benthem, et al.  
“Three-dimensional imaging of individual hafnium atoms inside a semiconductor”  
Applied Physics Letters, 87 03104 (2005)



# The Basic Idea: Cryogenic Temperatures



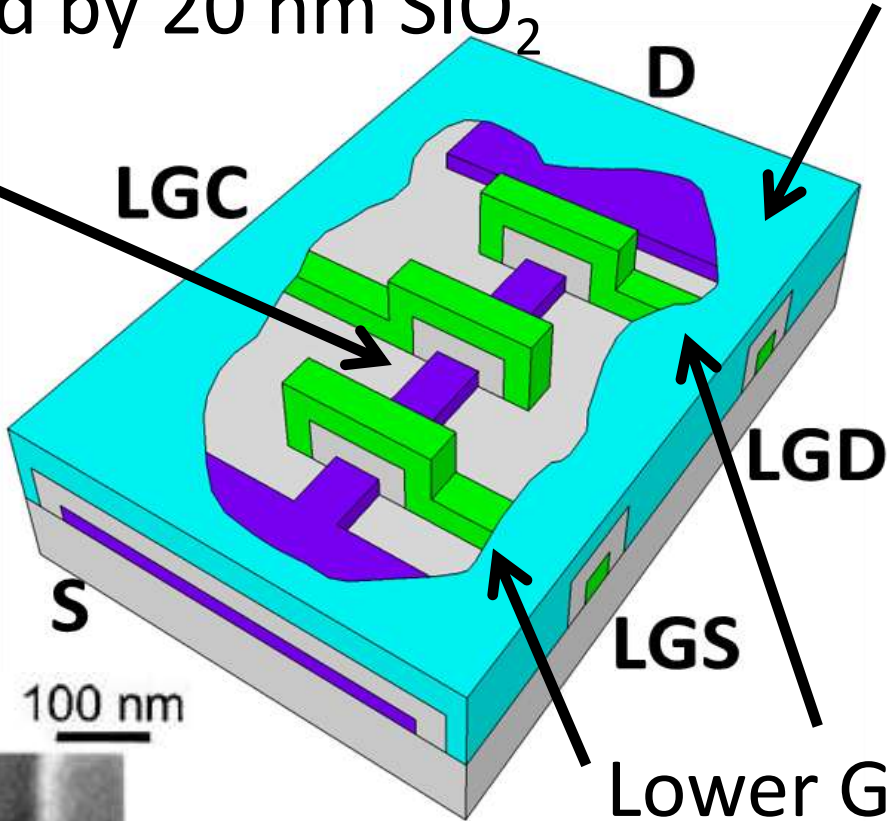
# The Basic Idea: Coulomb Blockade



# Nanowire ■

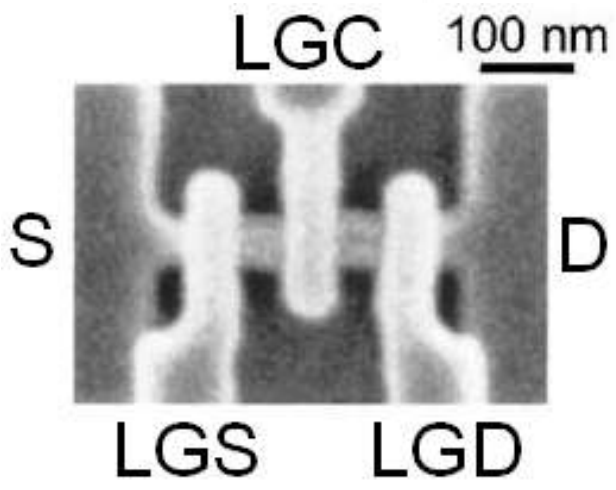
- ~20 nm x 20 nm x 500 nm
- Surrounded by 20 nm SiO<sub>2</sub>

Upper Gate ■  
• Heavily doped Poly



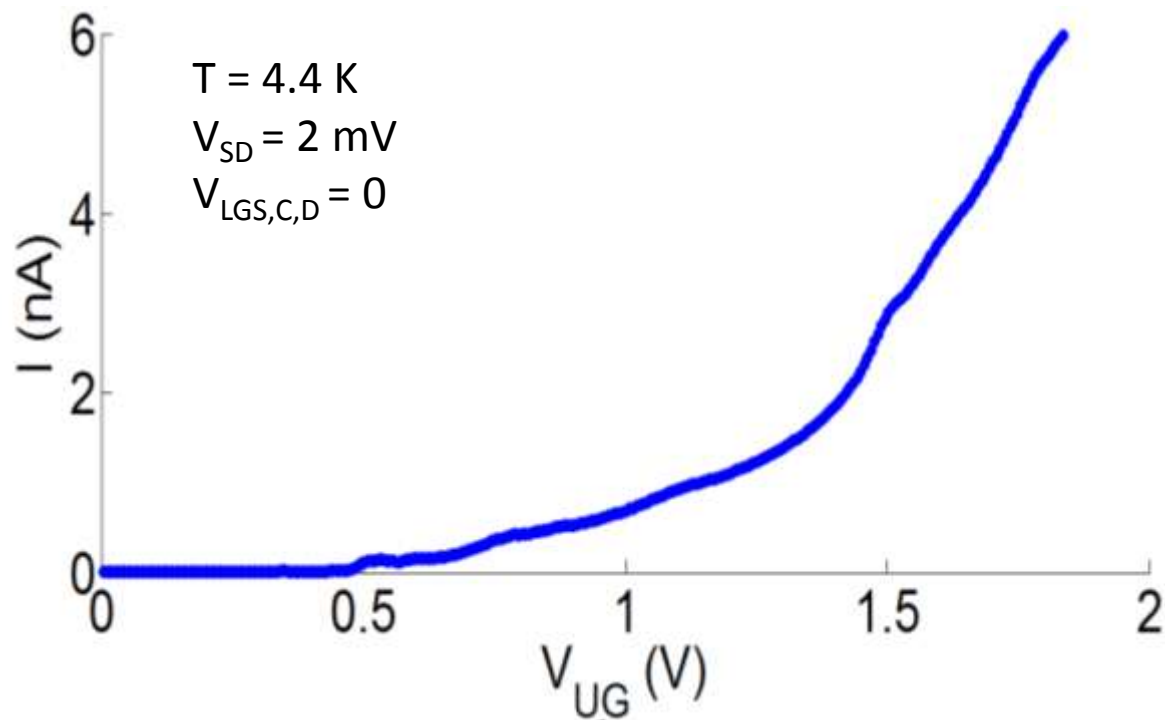
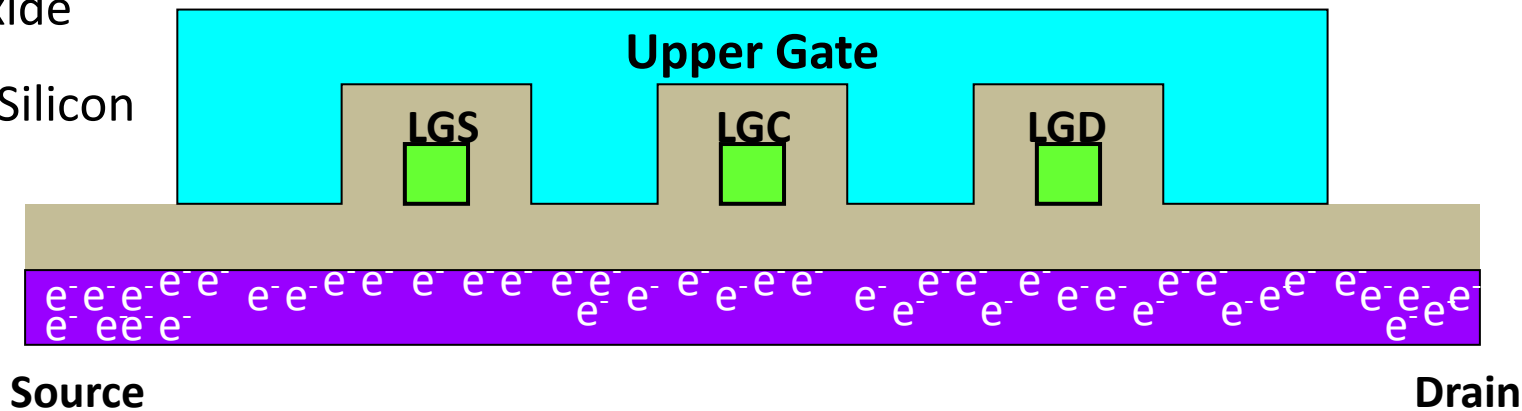
A. Fujiwara, et al.  
APL 88, 053121 (2006)

Lower Gates ■  
• Heavily doped Poly  
• 10 – 40 nm long  
• 3 independent gates



# Positive voltage on upper gate inverts wire

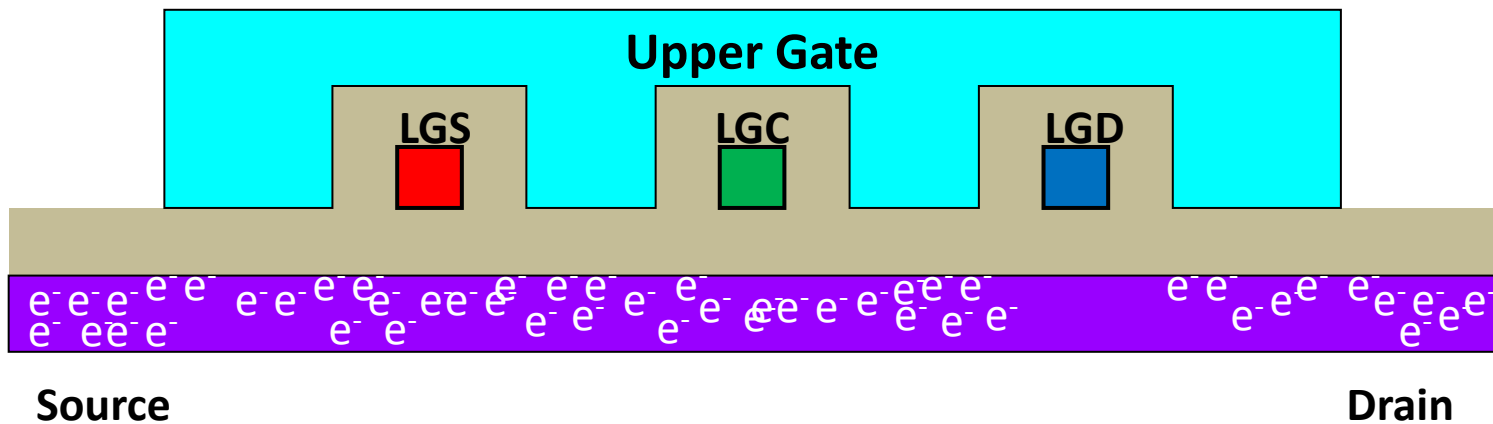
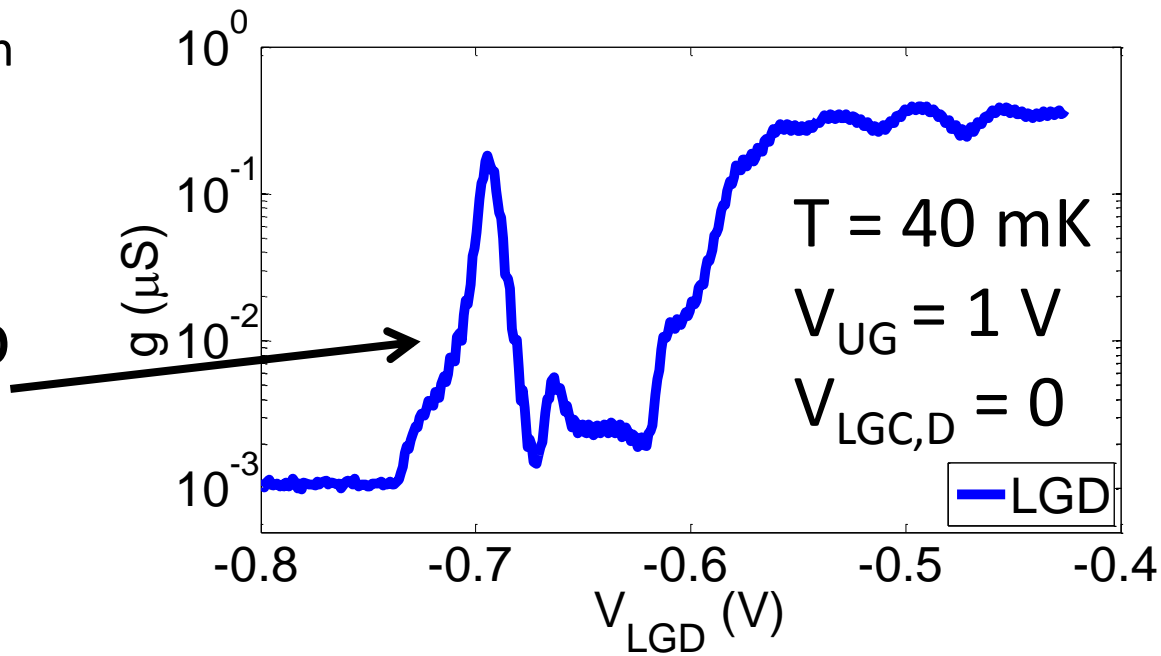
-  Poly Upper Gate
-  Poly Lower Gate
-  Silicon Dioxide
-  Crystalline Silicon



-  Poly Upper Gate
-  Poly Lower Gate
-  Silicon Dioxide
-  Crystalline Silicon

Negative voltages on lower gates form tunnel barriers

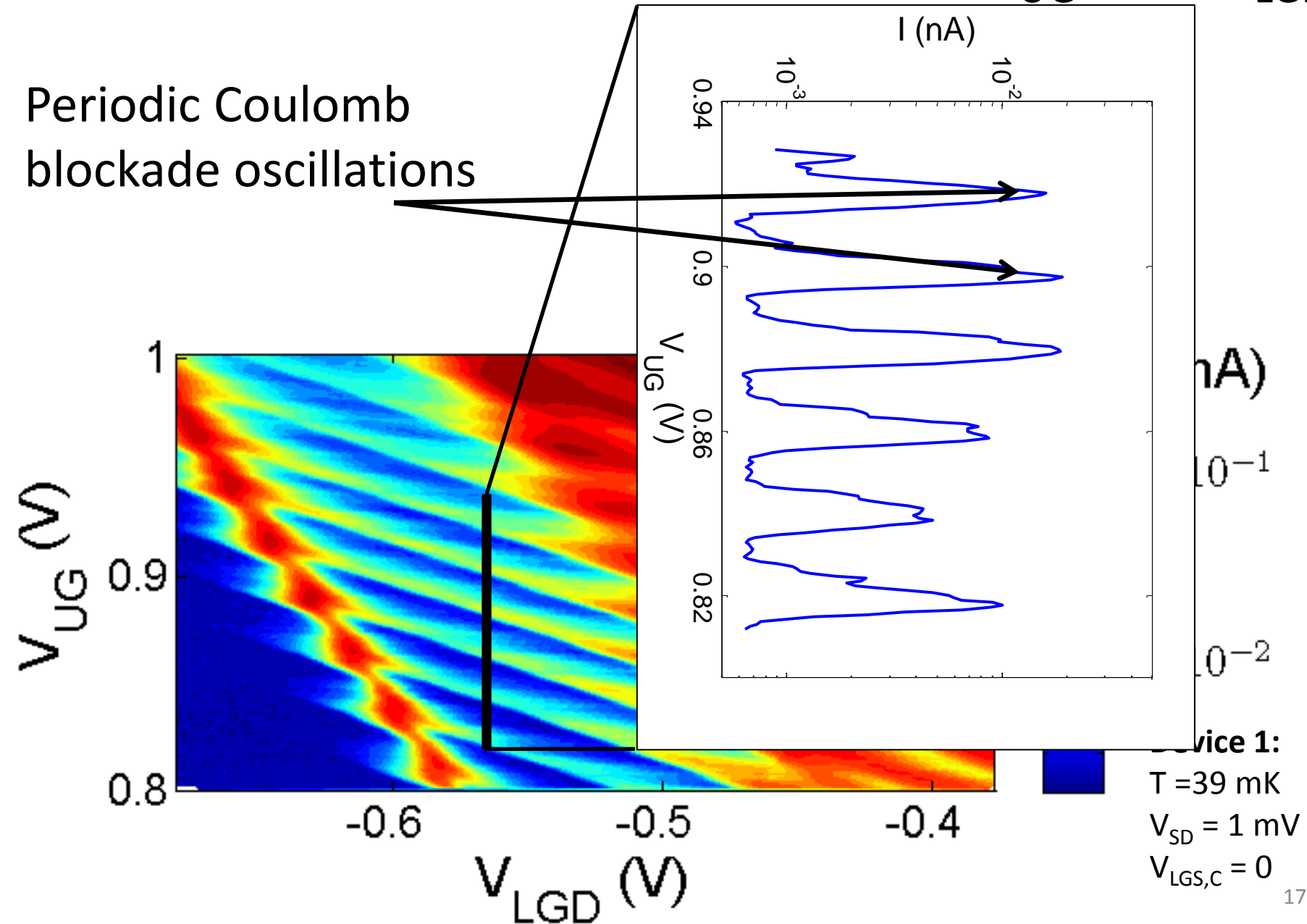
Peaks correspond to transport through QDs



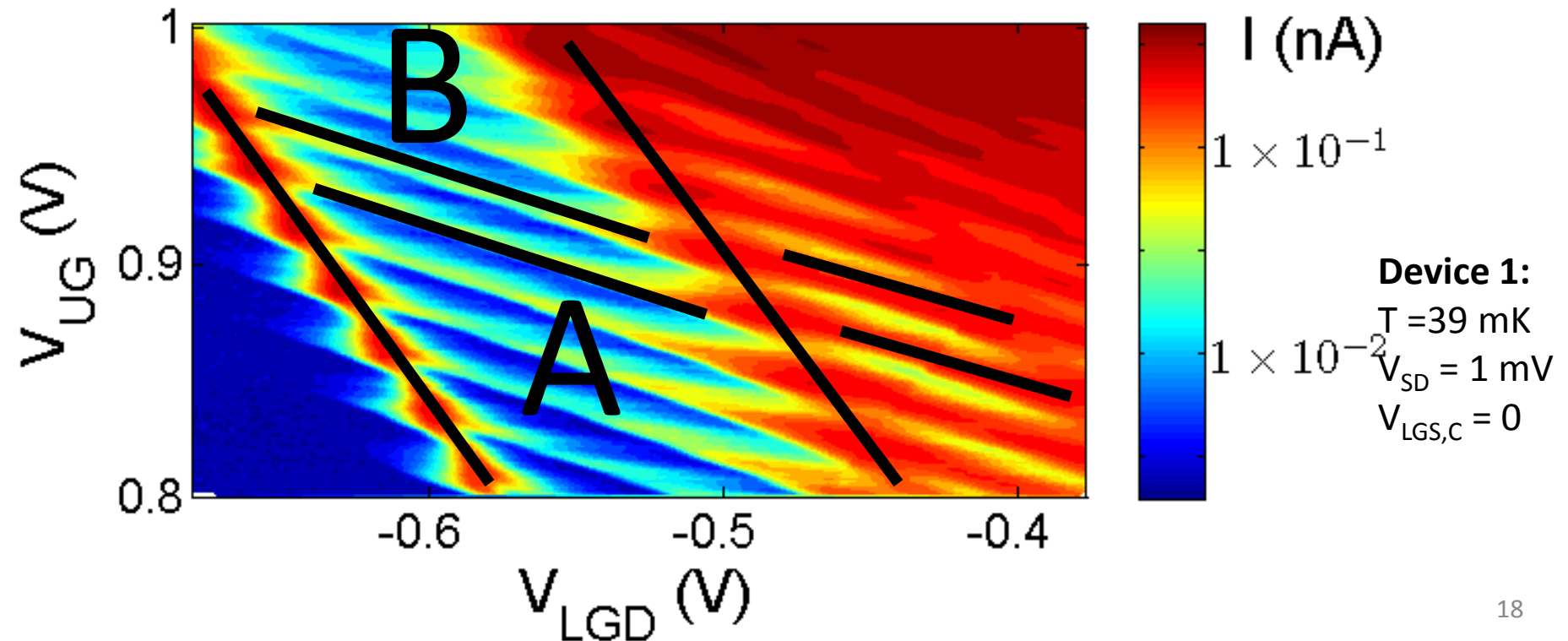


# Measure current while scanning $V_{UG}$ and $V_{LGD}$

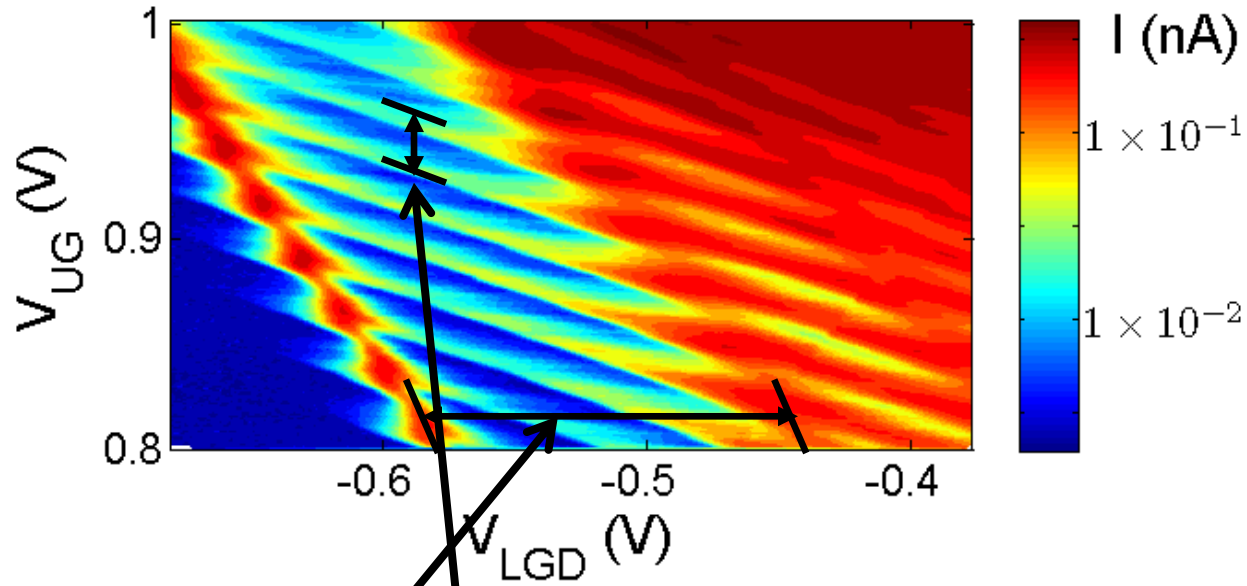
Periodic Coulomb  
blockade oscillations



- 2 flavors of QDs
  - A: few periods, more strongly coupled to LGD
  - B: many periods, more strongly coupled to UG

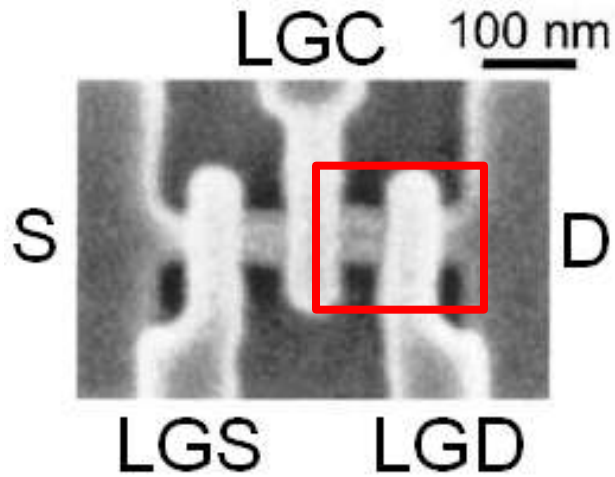


# Measure Gate Capacitances

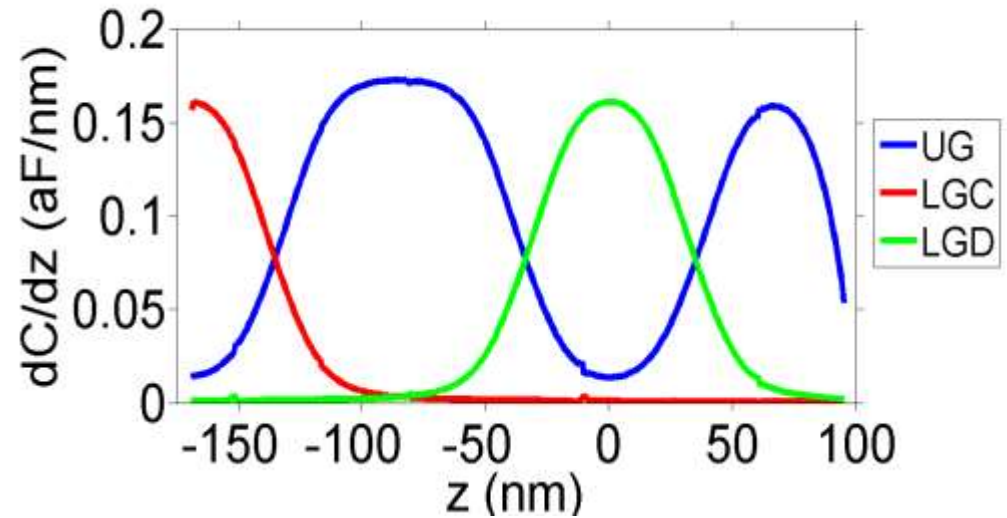
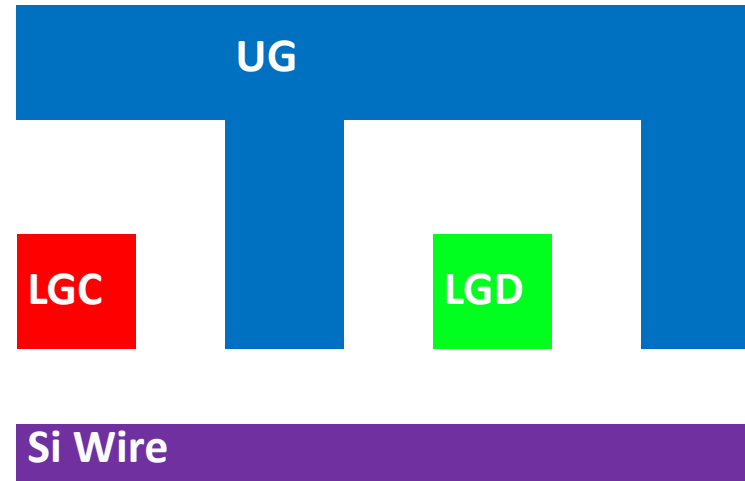


	LGD (aF)	UG (aF)	Ratio LGD/UG	LGC (aF)
<b>Dev. 1: Dot A</b>	$2.3 + 0.3 - 1.3$	$1.3 + 0.2 - 0.6$	$1.71 \pm 0.02$	$< 0.1$
<b>Dev. 1: Dot B</b>	$3.2 \pm 0.2$	$7.9 \pm 0.3$	$0.41 \pm 0.01$	$< 0.1$

# Locate the Dot



Simulated  $\frac{1}{2}$  device  
in FASTCAP

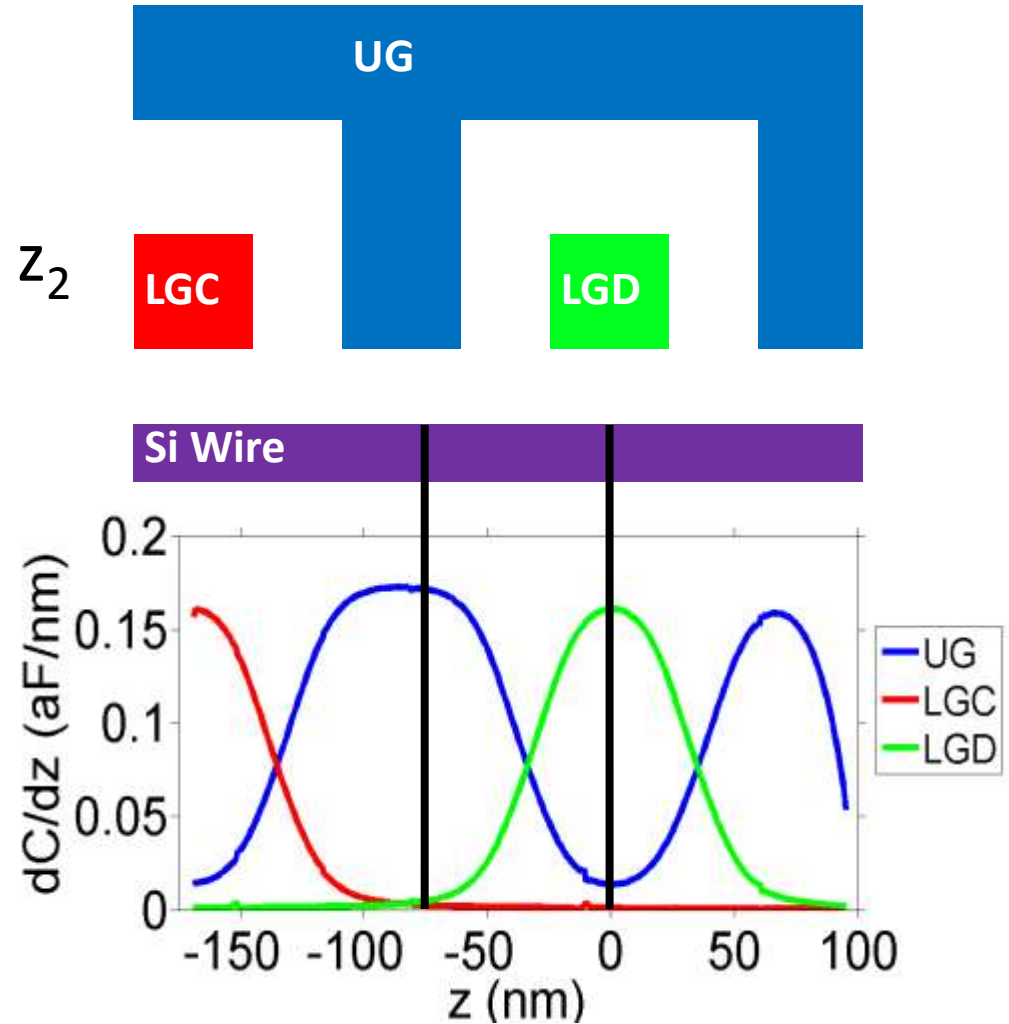


# Locate the Dot

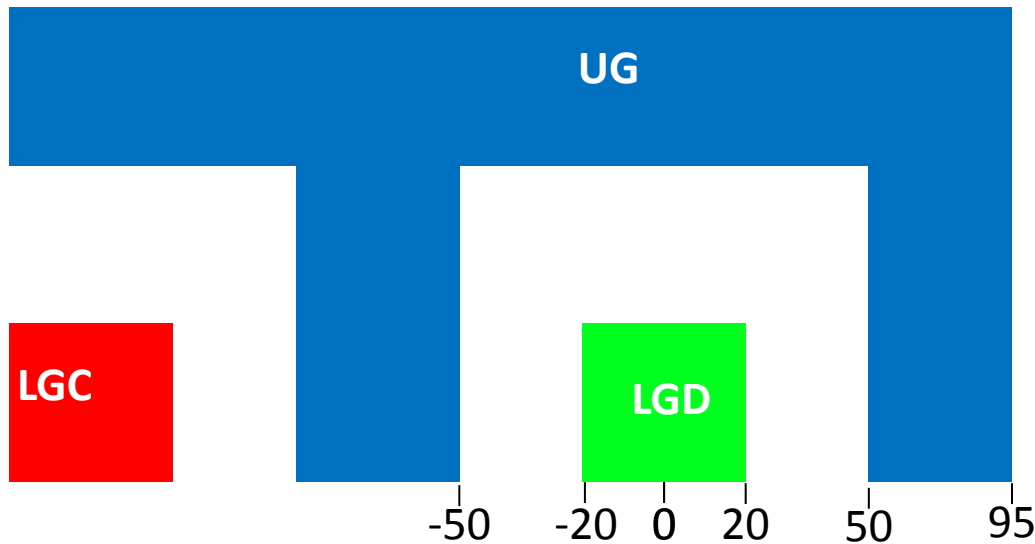
- Measure gate capacitances
- Simulate capacitances to 1 nm slices of wire
- Integrate between  $z_1$  and  $z_2$

$$C_{sim} = \int_{z_1}^{z_2} \frac{dC}{dz} dz$$

- For what  $z_1$  and  $z_2$  does  $C_{sim} = C_{meas}$  for all gates



	LGD (aF)	UG (aF)	Ratio LGD/UG	LGC (aF)
<b>Dev. 1: Dot B</b>	$3.2 \pm 0.2$	$7.9 \pm 0.3$	$0.41 \pm 0.01$	$< 0.1$

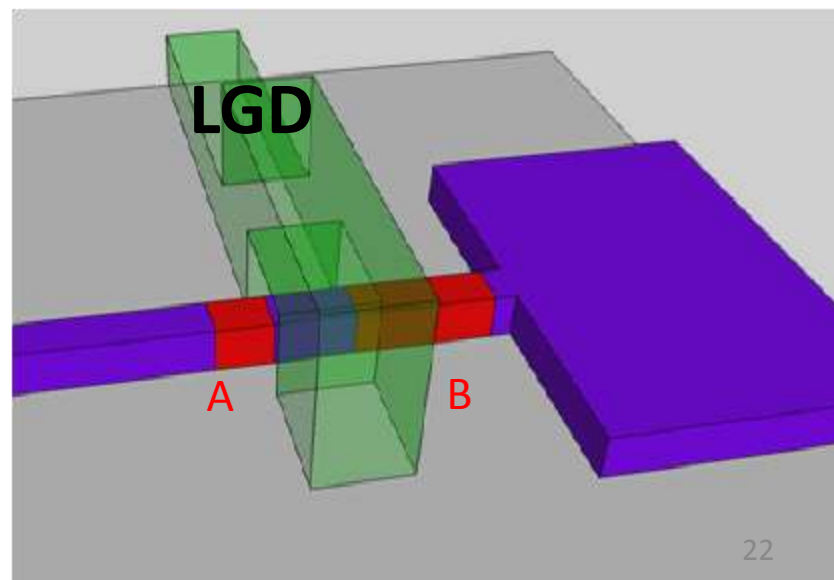


# Location of Dots



$z_1 = -40 \pm 3$        $z_1 = 17 \pm 1$        $z_2 = 87 \pm 2$   
 $z_2 = -19 \pm 3$

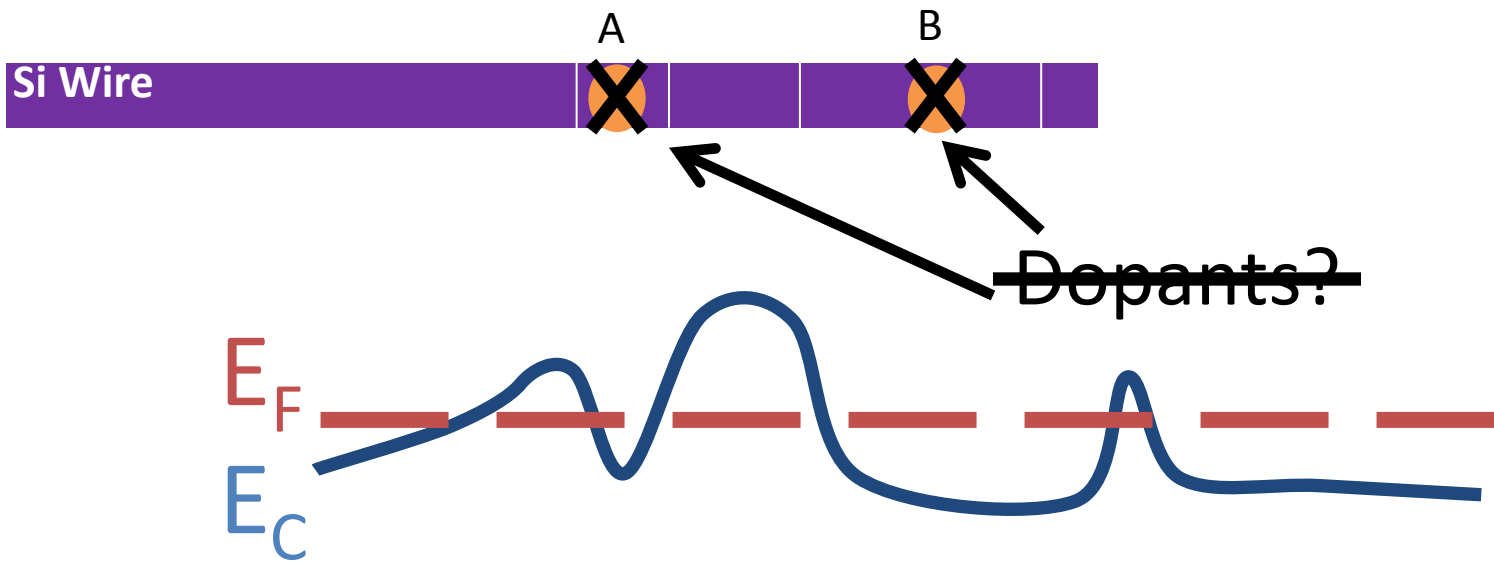
Between LGD and UG



# ~~Dopant Location?~~

We see same QDs in multiple devices

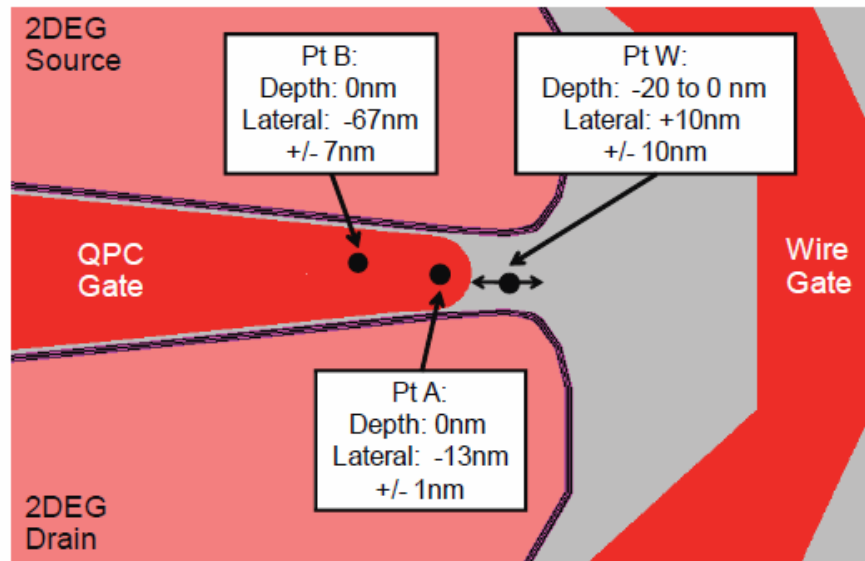
- The cause appears systematic
- Strain from temperature change and oxide growth
- Could help make faster finFETs



Deduced conduction band modulation

# Finding a Dopant

- Very similar technique has been used to locate individual dopants and interface traps
  - Nathaniel Bishop, et al; “Triangulating tunneling resonances in a point contact” Arxiv 1107.5104 (2011)

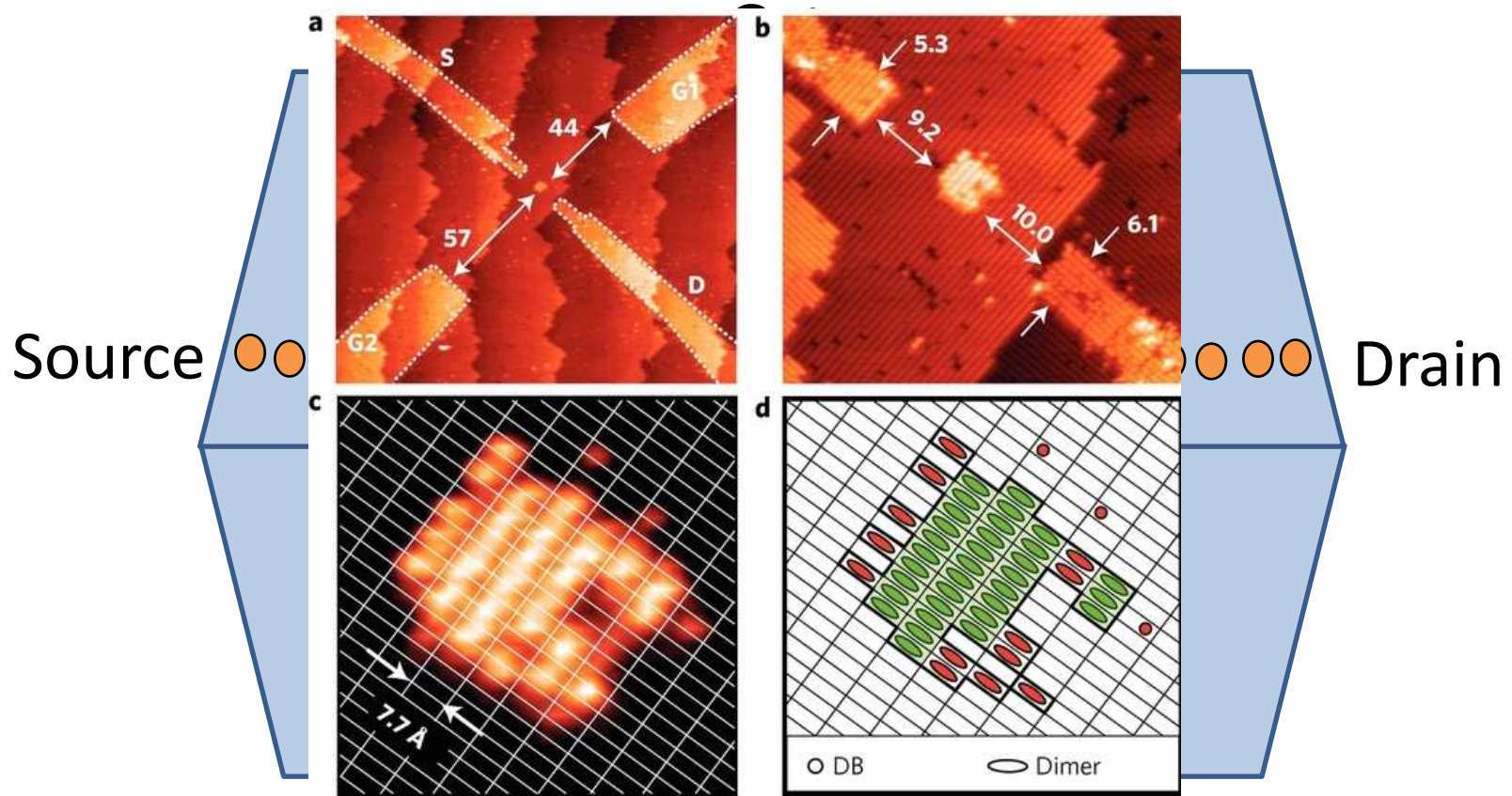




# Outline

- The impact of a single atom on a MOSFET
- Locating a single atom in a transistor
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# Ultimate Transistor?



Similar to:

Cheng Cen, et al. "Oxide Nanoelectronics on Demand" *Science* 323, 1026 (2009)

Martin Fueschsle, et al. "Spectroscopy of few-electron single-crystal silicon quantum dots" *Nature Nano*, 5, 502 (2010)

# Beyond the transistor

- World looks different on the atomic-scale
  - Quantum regime
- This is a problem for current transistors
  - Tunneling to the gate
- Could this “quantumness” become useful

# Quantum Search



“Classical” Computer: To search x100 boxes takes x100 as long

“Quantum” Computer: To search x100 boxes takes x10 as long

Number of Boxes	Old Computer	New Computer	Quantum Computer
10	10 $\mu$ s	10 ns	10 ns
1000	1000 $\mu$ s	1000 ns	100 ns

# Conclusions

- MOSFETs are reaching the point where the placement of a single atom can affect device performance
- New tools allow the location of a single atom to be determined within a MOSFET
- The quantum nature of a single atom could one day allow for much more powerful devices

# Collaborators

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